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03560.002558.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: H. Nguyen
Yuji SUDOH et al.)	
	:	Group Art Unit: 2851
Application No.: 09/532,022)	
	:	
Filed: March 21, 2000)	
	:	
For: EXPOSURE APPARATUS AND A)	
DEVICE MANUFACTURING METHOD	:	
WHICH KEEP TEMPERATURE OF A)	
DIAPHRAGM OF A PROJECTION	:	
OPTICAL SYSTEM SUBSTANTIALLY)	
CONSTANT	:	April 7, 2004

The Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT

Sir:

In response the Notice of Non-Compliant Amendment mailed March 23, 2004, a corrected "IN THE CLAIMS" section is submitted.